

## Electrodeposited Porous Copper Structures for Next-Generation Air-Cooled Two-Phase Heat Dissipation Technology

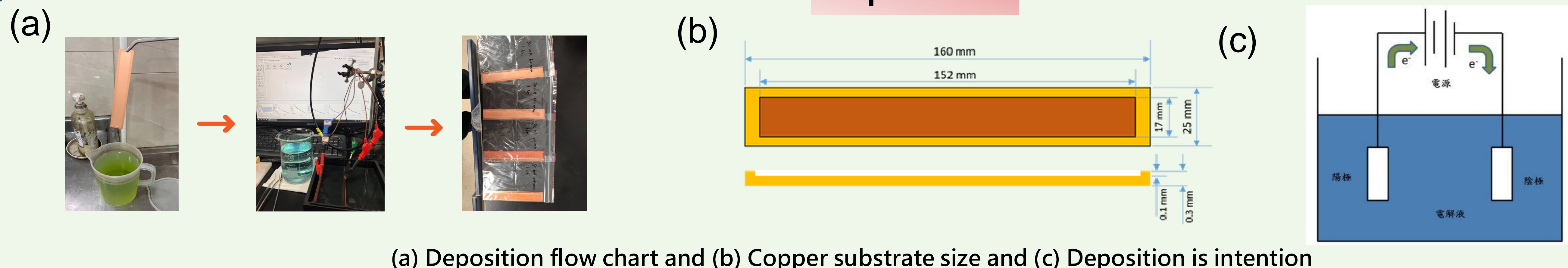
Zheng-Xian Ji<sup>1</sup>

<sup>1</sup>Department of Materials Engineering, Ming Chi University of Technology, New Taipei City, 24301, Taiwan

### Abstract

This study investigates the process of preparing porous copper structures using electrochemical deposition and systematically examines the effects of various parameters on structural morphology. Key factors such as current density, pH value, deposition time, temperature, and additives were controlled in the experiments. Through scanning electron microscopy (Scanning Electron Microscope, SEM), (X-ray photoelectron spectroscopy, XPS) characterization, we observed that these parameters significantly influence the formation and growth of porous structures. Results indicate that an electrolyte with a pH value of 2.3 produces optimal deposition effects. At a temperature of 60°C, the porous structure becomes more pronounced. Optimization of current density and deposition time is crucial for controlling the uniformity and density of the pore structure. Furthermore, the addition of PEG as an additive improves the flatness of the deposited layer. This research provides important guidance for preparing porous copper structures with controllable morphology, which have potential applications in fields such as catalysis and energy storage.

### Experiment



(a) Deposition flow chart and (b) Copper substrate size and (c) Deposition is intention

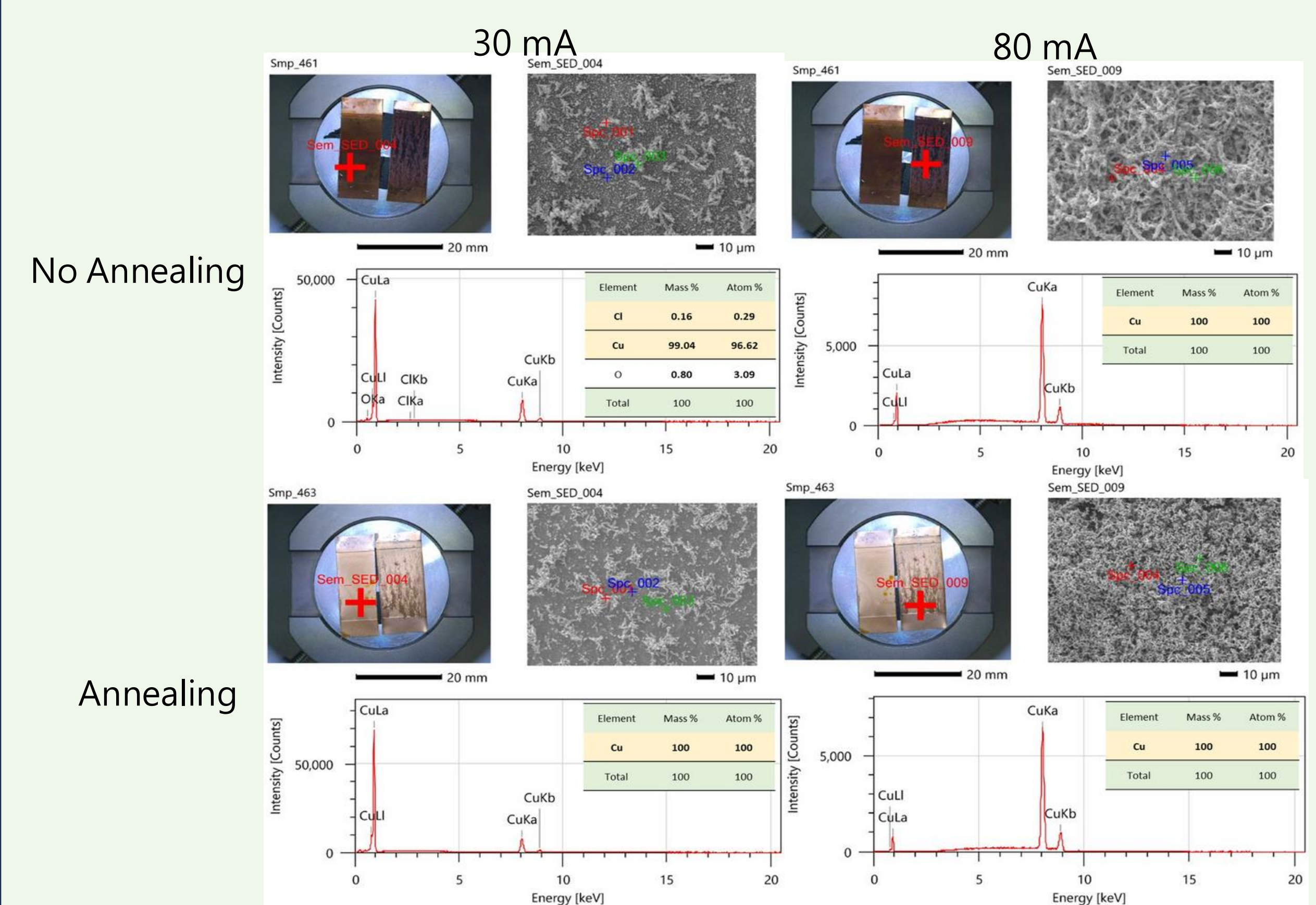
### Characterization

Different pH values: 0.3 (red), 2.95 (yellow), 2.3 (blue). Deposition distance: 10 mm. Deposition temperature: Ambient temperature.

	10 mA	15 mA	20 mA	25 mA	30 mA	80 mA	100 mA
5 min							
10 min							
15 min							
60 min							

It has been observed that a pH of 2.3 yields the best deposition results

### Characterization



Different current densities and EDS before and after annealing

### Characterization

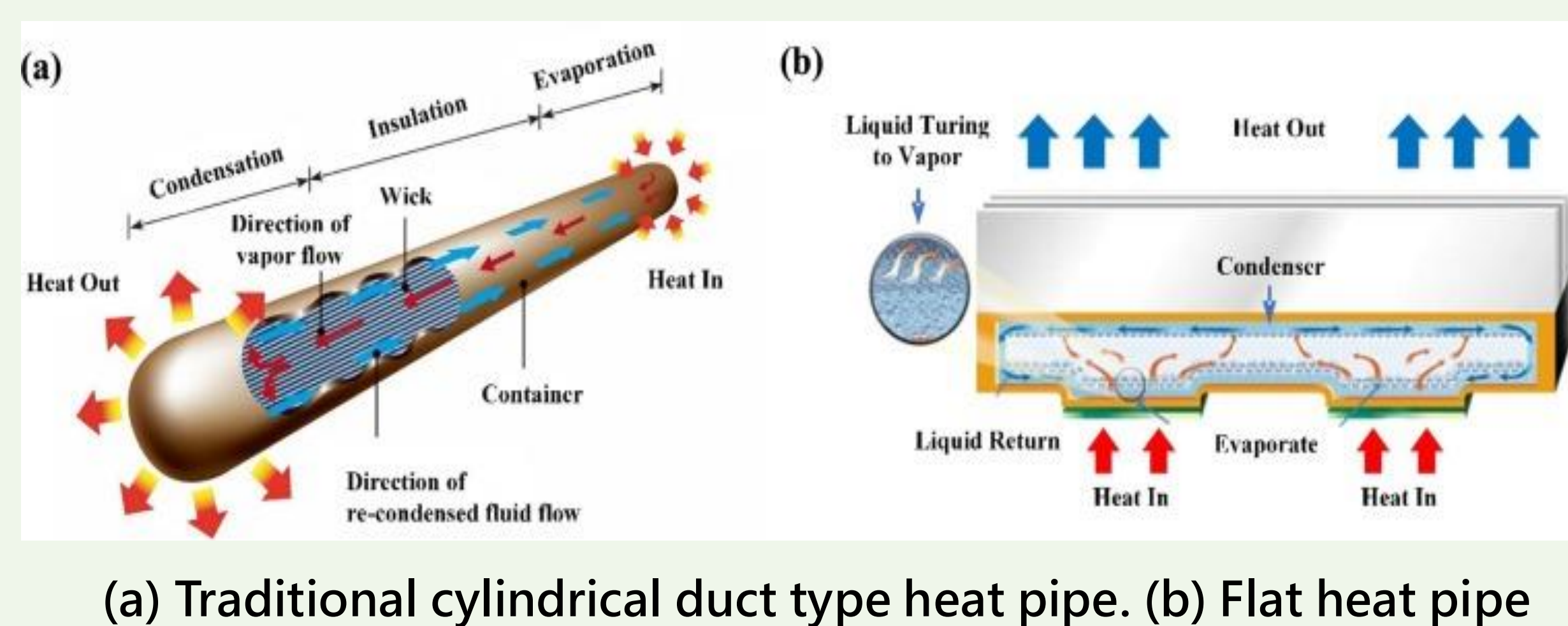
Different deposition temperatures: 60°C, 70°C. Deposition distance: 10 mm. pH value: 2.3.

80 mA	10 min	30 min	60 min	75 min	90 min	120 min
60°C						
70°C						

Variation of constant current and constant voltage under different temperatures and times

2 V	30 min	60 min
60°C		

### Mechanism



(a) Traditional cylindrical duct type heat pipe. (b) Flat heat pipe

### Conclusion

1. An acidic environment can corrode the substrate, while an alkaline environment is unsuitable for optimal copper deposition. A pH of 2.3 gives the best results.
2. At a bath temperature of 60°C, constant current creates a more porous deposition. Under the same temperature, constant voltage leads to overly dense deposition.
3. Adding PEG reduces the uniformity of the deposition layer; 1 to 3 grams of PEG is ideal

Alternating current, voltage, and the addition of different amounts of additives

### Characterization

Deposition distance: 10 mm. pH value: 2.3.

-0.1 V 30 min	-0.5 V 30 min	-0.1 V / 15 min 80 mA / 15 min TTL 30 min	-0.1 V / 5 min 80 mA / 5 min TTL 10 min	-0.1 V / 5 min 80 mA / 5 min rpt. 3 TTL 30 min
Adding different amounts under the same voltage and current PEG (g)				
1 g	2 g	3 g	4 g	5 g

The amount of PEG added is inversely proportional to the uniformity of the deposition layer